

INFORMATION DISCLOSURE STATEMENT

Applicant	:	Watanabe, et al.
App. No	:	10/574,073
Filed	:	March 30, 2006
For	:	RESIST COMPOSITION FOR ELECTRON BEAM OR EUV
Examiner	:	Amanda C. Walke
Art Unit	:	1752

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 19 references to be considered by the Examiner. Also enclosed are 13 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 9/20/07

By: 

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